

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/617,532	NAKAYAMA, M	ASATOSHI
Examiner	Art Unit	
Tianjie Chen	2652	

SEARCHED					
Class	Subclass	Date	Examiner		
360	122				
	126				
	234.5				
	235.2				
216	22	5/23/2005	TJ		
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Esat Report	5/23/2005	ΤJ	
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